



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Michael T. Andreas

Serial No.: 10/665,238

Filed: September 17, 2003

For: METHOD FOR THE POST-ETCH
CLEANING OF MULTI-LEVEL
DAMASCENE STRUCTURES HAVING
UNDERLYING COPPER
METALLIZATION

Confirmation No.: 6261

Examiner: M. Lebentritt


Group Art Unit: 2824

Attorney Docket No.: 2269-5981US
(02-1592.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

December 1, 2004
Date


Signature

Leah J. Barrow
Name (Type/Print)

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed September 1, 2004, the three-month shortened statutory period for response to which expires on December 1, 2004.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 7 of this paper.

Amendments to the Drawings appear on page 10 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks begin on page 11 of this paper.

An **Appendix** including amended drawing figures is attached following page 13 of this paper.